



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Daniel KOPF et al.

Group Art Unit: 2828

Application No.: 10/581,893

Examiner: S. HAGAN

Filed: September 29, 2006

Docket No.: 120391

For: HIGH-REPETITION LASER SYSTEM FOR GENERATING ULTRA-SHORT PULSES
ACCORDING TO THE PRINCIPLE OF PULSE DECOUPLING

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed with a Request for Continued Examination. No certification or fee is required.
- ☒ 2. One or more reference cited herein was cited in a counterpart foreign application. See Reference(s) 1. An original and English language version of the foreign Office Action is attached for the Examiner's information as Reference 2.
- ☒ 3. An English language Abstract of one or more non-English language reference is included. See Reference(s) 1.

- ☒ 4. U.S. Patent no. 6,807,198, cited in the June 28, 2010 Information Disclosure Statement, corresponds to Reference 1.

Respectfully submitted,



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Date: September 17, 2010

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